

Notice of References Cited	Application/Control No. 10/791,197		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Anastasia Midkiff		Art Unit 2882	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,437,506	08-2002	Mitamura et al.	313/586
	C	US-			
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	F	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Derwent Abstract for Korean Patent to Ahn, SI, (DERWENT ACC NO 2002-250998), Korean Patent Number (KR 2001046093A), Published June 5, 2001.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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